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ATTORNEY DOCKET NO. 2522-043
CLIENT REF. NO. AW8089US/JY

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Han-Mei CHOI, et al.

Serial No.: 10/737,394

Examiner: Not yet assigned

Filing Date: December 15, 2003

Group Art Unit: 2812

Confirmation No.: 7607

Title: METHOD FOR FORMING A MULTI-LAYERED STRUCTURE OF A SEMICONDUCTOR DEVICE AND METHODS FOR FORMING A CAPACITOR AND A GATE INSULATION LAYER USING THE MULTI-LAYERED STRUCTURE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- ☐ under 37 CFR 1.97 (b); or
(Within three months of filing national application; or date of entry of International application; or before mailing date of first office action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under §1.114; whichever occurs last)
- ☒ under 37 CFR 1.97 (c) together with either a:
☒ Statement under 37 CFR 1.97 (e), or
☐ a \$180 fee under 37 CFR 1.17 (p); or
(After mailing of first Office Action, but prior to Notice of Allowance or Final Office Action)
- ☐ under 37 CFR 1.97 (d) together with:
☐ Statement under 37 CFR 1.97 (e), and
☐ a \$180.00 fee set forth in 37 CFR 1.17 (p).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted,
MARGER JOHNSON & McCOLLOM, P.C.

Hosoon Lee
Limited Recognition Under 37 CFR § 10.9(b)

MARGER JOHNSON & McCOLLOM, P.C.
1030 SW Morrison Street
Portland, OR 97205
503-222-3613

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
Date: February 8, 2005

Stormi R. Davis



PATENT APPLICATION
Attorney's Doc. No. 2522-043
Client Ref. No. AW8089US/JY

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STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT
(37 CFR 1.97(e))

I, Hosoon Lee, the person signing below state that:


each item of information contained in the Information Disclosure Statement submitted herewith was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement

no information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing this Statement after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the Statement.

Applicant respectfully requests consideration of the accompanying Information Disclosure Statement.

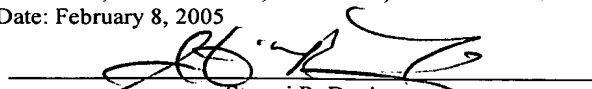
The person making this Statement is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,
MARGER JOHNSON & McCOLLOM, P.C.


Hosoon Lee
Limited Recognition Under 37 CFR § 10.9(b)

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Group: 2812

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
_____	_____	6108937	Aug. 29, 00	Ivo Raaijmakers		

FOREIGN PATENT DOCUMENTS

Exam Init	Ref	Document Number	Publication Date	Country	Name
_____	_____	01108659	Dec. 8, 01	Korea	Gi-Yeon PRAK

OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)
_____	_____	English language abstract of Korean Publication No. 01108659

Examiner: _____

Date Considered: _____